

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 031072	Serial No. New Appln. 10/648483
	Applicant(s): Toshiaki NAGAI	
	Filing Date: August 27, 2003	Group Art Unit: 2878

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<u>SYE</u>	AA	5,004,307	Kino et al.			04/02/91
<u>SYE</u>	AB	5,939,709	Ghislain et al.			08/17/99
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<u>SYE</u>	AF	M. H. Kryder et al.; Journal of Applied Physics, Vol. 40, No.6, pp.2469-2474.
<u>SYE</u>	AG	M. R. Freeman et al.; J. Appl. Phys. 79 (8), April 15, 1996.
<u>SYE</u>	AH	Nonaka et al.; Semiconductor and Material Department Meeting of Electronic Society, 1983, p. 48.
<u>SYE</u>	AI	Patent Abstracts of Japan, Pub. No. 05215828, dated Aug. 27, 93.
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<u>SYE</u>	AK	W.W. Clegg et al.; Journal of Magnetism and Magnetic Materials, Vol. 95, pp.49-57, 1991.
<u>SYE</u>	AL	R.J.M. van de Veerdonk et al.; Journal of Magnetism and Magnetic Material, Vol. 235, pp.138-142, 2001.
<u>SYE</u>	AM	H. Ohmori, Journal of Magnetic Society of Japan, Vol. 23, No. 12, pp.2111-2117, 1999.
<u>SYE</u>	AN	E. Betzig et al.; Applied Physics Letters, Vol. 61, No. 2, July 1992.

Examiner <u>Suzanne Ellis</u>	Date Considered	12 MAY 05
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